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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

NONOYAMA et al

Atty. Ref.: 461-168

Serial No. 10/800,020

TC/A.U.: 1755

Filed: March 15, 2004

Examiner:

For: CRYSTAL ORIENTED CERAMICS AND PRODUCTION METHOD
OF SAME

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December 21, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

Attention is directed to the attached Chinese Office Action in a counterpart of this application and to a copy of each non US patent document newly cited therein. A Form PTO-1449 is also attached.

Official consideration and citation of all identified documents is requested.

Respectfully submitted,

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INFORMATION DISCLOSURE CITATION

ATTY. DOCKET NO.

461-168

APPLICANT

NONOYAMA et al

FILING DATE

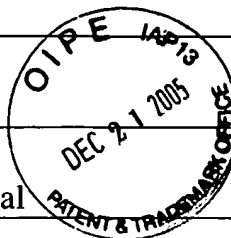
March 15, 2004

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1755



(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

[illegible]

***Examiner**

Date Considered

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.